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*Rhonda N. Hunt*

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Docket: 0756-958

305-102

6p 2508

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re PATENT application of

Shunpei YAMAZAKI et al.

Serial No. 08/183,800

Filed: January 21, 1994

For: SEMICONDUCTOR MATERIAL  
AND METHOD FOR FORMING  
THE SAME AND THIN FILM  
TRANSISTOR

)  
)  
) Art Unit: 2508  
) Examiner: M. Saadat  
)  
)  
)  
) Date: February 3, 1995

*#21/E*  
*[Signature]*  
*3/7/95*

AMENDMENT

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir:

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In response to the Office Action of September 7, 1994, please amend the subject application as follows:

IN THE CLAIMS:

Cancel claims 5-14 without prejudice.

Add new claims 32-35.

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